

AMENDMENT UNDER 37 C.F.R. § 1.116  
EXPEDITED PROCEDURE  
GROUP 1734  
**PATENT APPLICATION**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of	Docket No: Q80074
Eun-sung LEE, et al.	
Appln. No.: 10/797,579	Group Art Unit: 1734
Confirmation No.: 4816	Examiner: Yewebdar T. TADESSE
Filed: March 11, 2004	
For: SPIN COATING APPARATUS FOR COATING PHOTORESIST	

**AMENDMENT UNDER 37 C.F.R. § 1.116**

**MAIL STOP AF**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated December 12, 2006, please amend the above-identified application as follows on the accompanying pages.

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